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U.S. Patent Application Serial No. 10/782,821

**AMENDMENTS TO THE CLAIMS:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

**Listing of Claims:**

Claim 1 (Currently Amended): A simulation method for simulating an amount of occurrence of

local flare which occurs in an exposure process using a photo mask in manufacturing a semiconductor device for use in optical corrections to obtain a more accurate optical image, comprising the steps of:

dividing a layout of a photo mask into a plurality of areas,

calculating an average value of light intensity in each of the areas, and

estimating the amount of occurrence of local flare in each of the areas on the basis of each of the average values, and

correcting dimensions of the photo mask based on the estimated amount of occurrence of local flare, wherein

when a circular-shaped light source is used, the average value of light intensity

$\bar{I} = \sum_{k=1}^N F_k S_k S_k^* [[...]]$ , and  $F_k$  is a weighting factor of diffracted light and  $S_k$  is the amplitude of

the diffracted light, and  $F_k = A_k / (\sigma^2 \pi)$  where  $A_k$  is the area shared between a circle C having a radius NA, the numerical aperture of the lens, and a circle  $S_k$  having a radius of the light source with respect to NA, and  $\sigma$  is the radius of the circular shaped light source with respect to NA, and

U.S. Patent Application Serial No. 10/782,821

when a ring-shaped light source is used,  $F_k = A_k / (\sigma_2^2 \pi - \sigma_1^2 \pi)$  where  $\sigma_1$  is the inside radius and  $\sigma_2$  is the outside radius of the ring-shaped light source with respect to NA.

Claim 2 (Original): The simulation method according to claim 1, wherein each of the average values is subjected to smoothing processing, a smoothed average value is multiplied by a first multiplier, and an obtained value is evaluated as the amount of occurrence of local flare in each of the areas.

Claim 3 (Original): The simulation method according to claim 1, wherein when the average value of light intensity in each of the areas is calculated, diffracted light is calculated by a Fourier transformed image of each of the areas of the layout, and the average value is calculated by multiplying the light intensity of the diffracted light passing through a projection lens by a second multiplier.

Claim 4 (Original): The simulation method according to claim 1, wherein each of the values evaluated as the amount of occurrence of local flare is added to the light intensity in order to simulate an optical image.

Claim 5 (Original): The simulation method according to claim 1, wherein each of the values evaluated as the amount of occurrence of local flare is used in optical proximity correction.

Claim 6 (Currently Amended): Simulation equipment for simulating an amount of occurrence of local flare which occurs in an exposure process in manufacturing a semiconductor device for use in optical corrections to obtain a more accurate optical image, comprising:

U.S. Patent Application Serial No. 10/782,821

division unit for dividing a layout of a photo mask into a plurality of areas;  
 average light intensity value calculation unit for calculating an average value of light intensity in each of the areas, and  
means for correcting dimensions of the photo mask based on the estimated amount of occurrence of local flare, wherein

the amount of occurrence of local flare in each of the areas is estimated on the basis of each of the average values, and

when a circular-shaped light source is used, the average value of light intensity  $\bar{I} = \sum_{k=1}^N F_k S_k S_k^* [[...]]$ , and  $F_k$  is a weighting factor of diffracted light and  $S_k$  is the amplitude of the diffracted light, and  $F_k = A_k / (\sigma^2 \pi)$  where  $A_k$  is the area shared between a circle C having a radius NA, the numerical aperture of the lens, and a circle  $S_k$  having a radius of the light source with respect to NA, and  $\sigma$  is the radius of the circular shaped light source with respect to NA, and

when a ring-shaped light source is used,  $F_k = A_k / (\sigma_2^2 \pi - \sigma_1^2 \pi)$  where  $\sigma_1$  is the inside radius and  $\sigma_2$  is the outside radius of the ring-shaped light source with respect to NA.

Claim 7 (Original): The simulation equipment according to claim 6 further comprising:  
 smoothing unit for subjecting the calculated average value to smoothing processing, and  
 multiplication unit for multiplying the smoothed average value by a first multiplier,  
 wherein each obtained value is evaluated as the amount of occurrence of local flare in each of the areas.

U.S. Patent Application Serial No. 10/782,821

Claim 8 (Original): The simulation equipment according to claim 6, wherein  
when the average value of light intensity in each of the areas is calculated, diffracted light is calculated by a Fourier transformed image of each of the areas of the layout, and the average value is calculated by multiplying the light intensity of the diffracted light passing through a projection lens by a second multiplier.

Claim 9 (Original): The simulation equipment according to claim 6, wherein  
each of the values evaluated as the amount of occurrence of local flare is added to the light intensity in order to simulate an optical image.

Claim 10 (Original): The simulation equipment according to claim 6, wherein  
each of the values evaluated as the amount of occurrence of local flare is used in optical proximity correction.

Claim 11 (Currently Amended): A computer having a computer-readable storage medium on which a computer program for use in optical corrections to obtain a more accurate optical image for simulating an amount of occurrence of local flare which occurs in an exposure process in manufacturing a semiconductor is stored, said computer program comprising:

a computer-readable program code means for executing a step of dividing a layout of a photo mask into a plurality of areas;

a computer-readable program code means for executing a step of calculating an average value of light intensity in each of the areas; and

U.S. Patent Application Serial No. 10/782,821

a computer-readable program code means for executing a step of simulating and estimating an amount of occurrence of local flare in each of the areas on the basis of each of the average values, for use in optical corrections to obtain a more accurate optical image, and means for correcting dimensions of the photo mask based on the estimated amount of occurrence of local flare, wherein

when a circular-shaped light source is used, the average value of light intensity  $\bar{I} = \sum_{k=1}^N F_k S_k S_k^* [[...]]$ , and  $F_k$  is a weighting factor of diffracted light and  $S_k$  is the amplitude of the diffracted light, and  $F_k = A_k / (\sigma^2 \pi)$  where  $A_k$  is the area shared between a circle C having a radius NA, the numerical aperture of the lens, and a circle  $S_k$  having a radius of the light source with respect to NA, and  $\sigma$  is the radius of the circular shaped light source with respect to NA, and

when a ring-shaped light source is used,  $F_k = A_k / (\sigma_2^2 \pi - \sigma_1^2 \pi)$  where  $\sigma_1$  is the inside radius and  $\sigma_2$  is the outside radius of the ring-shaped light source with respect to NA.

Claim 12 (Currently Amended): A computer having a computer program product for use in optical corrections to obtain a more accurate optical image for simulating an amount of occurrence of local flare which occurs in an exposure process in manufacturing a semiconductor, comprising:

a computer-readable program code means for executing a step of dividing a layout of a photo mask into a plurality of areas; a computer-readable program code means for executing a step of calculating an average value of light intensity in each of the areas; and

a computer-readable program code means for executing a step of simulating and

U.S. Patent Application Serial No. 10/782,821

estimating an amount of occurrence of local flare in each of the areas on the basis of each of the average values for use in optical corrections to obtain a more accurate optical image, and

means for correcting dimensions of the photo mask based on the estimated amount of occurrence of local flare, wherein

when a circular-shaped light source is used, the average value of light intensity

$$\bar{I} = \sum_{k=1}^N F_k S_k S_k^* [[...]], \text{ and } F_k \text{ is a weighting factor of diffracted light and } S_k \text{ is the amplitude of}$$

the diffracted light, and  $F_k = A_k / (\sigma^2 \pi)$  where  $A_k$  is the area shared between a circle  $C$  having a radius  $NA$ , the numerical aperture of the lens, and a circle  $S_k$  having a radius of the light source with respect to  $NA$ , and  $\sigma$  is the radius of the circular shaped light source with respect to  $NA$ , and

when a ring-shaped light source is used,  $F_k = A_k / (\sigma_2^2 \pi - \sigma_1^2 \pi)$  where  $\sigma_1$  is the inside radius and  $\sigma_2$  is the outside radius of the ring-shaped light source with respect to  $NA$ .